

Substitute Form PTO-1449
(Modified)U.S. Department of Commerce
Patent and Trademark OfficeAttorney's Docket No
05770-097001Application No
09 615,999**Information Disclosure Statement
by Applicant**

(Use several sheets if necessary)

CFR §1.98(b)(1)

Applicant

Wei Zhang, Martin W. Rupich, Suresh
Annavarapu, Leslie G. Fritzemeier, Edward J.
Siegal, Valery PrunierFiling Date
July 14, 2000

Group Art Unit

U.S. Patent Documents

Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
ST	AL	0308869	20.09.88	Europe				
I	AM	WO92/05591	02.04.92	PCT				
DS	AN	0506582A2	30.09.92	Europe				
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
ST	AQ	He et al., "Growth of Biaxially Oriented Conductive LaNiO ₃ Buffer Layers on Textured Ni Tapes for High-T _c -Coated Conductors," <i>Physica C</i> 314 (1999) p. 105-111
I	AR	Koster et al., "Influence of the Surface Treatment on the Homoepitaxial Growth of SrTiO ₃ ," <i>Materials Science & Engineering B56</i> (1998) p. 209-212
I	AS	Tanaka et al., "Improvement of YBa ₂ Cu ₃ O _{7-x} Single-Crystal Surface by Chemical Etching," <i>Jpn. J. Appl. Phys. Vol. 38</i> (1999) p. L731-L733
DS	AT	International Search Report

Examiner Signature

Date Considered

EXAMINER: Initials citation considered Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant

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U.S. Patent Documents

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BT	AA	5,231,074	07-27-93	Cima et al.			
	AB						
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BT	AL	WO 98/58415	12-23-93					
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	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
BT	AQ	Smith, J.A. et al., "High Critical Current Density Thick MOD-Derived YBCO Films." Transactions on Applied Superconductivity, Vol. 9, No. 2, June 1999
	AR	
	AS	
	AT	

Examiner Signature

D. Taib

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